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Bib Data Sheet

CONFIRMATION NO. 3898

SERIAL NUMBER	FILING OR 371(c) DATE	CLASS	GROUP ART UNIT	ATTORNEY DOCKET NO.	
10/694,413	10/27/2003 RULE	438	1763	CS99-065CCB	
<b>APPLICANTS</b> Kwok Keung Paul Ho, Singapore, SINGAPORE; Xue Chun Dai, Singapore, SINGAPORE;  <b>** CONTINUING DATA *****</b> This application is a DIV of 09/442,499 11/18/1999 PAT 6,790,374 <i>gag 12-041</i>  <b>** FOREIGN APPLICATIONS *****</b> <i>gag 12-041</i>  <b>IF REQUIRED, FOREIGN FILING LICENSE GRANTED</b> <b>** 02/27/2004</b>					
Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after met Verified and <i>Allowance</i> Acknowledged <i>gag 12-041</i> Examiner's Signature Initials		STATE OR COUNTRY SINGAPORE	SHEETS DRAWING 2	TOTAL CLAIMS 17	INDEPENDENT CLAIMS 4
<b>ADDRESS</b> George O. Saile 28 Davis Avenue Poughkeepsie ,NY 12603					
<b>TITLE</b> Plasma etch method for forming plasma etched silicon layer					
<b>FILING FEE RECEIVED</b> 856	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		